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Bib Data Sheet

CONFIRMATION NO. 2218

<b>SERIAL NUMBER</b> 09/903,600	<b>FILING DATE</b> 07/12/2001 <b>RULE</b>	<b>CLASS</b> 356	<b>GROUP ART UNIT</b> 2877	<b>ATTORNEY DOCKET NO.</b> S004-4331	
<b>APPLICANTS</b> Ryoichi Matsuoka, Chiba-shi, JAPAN; <b>** CONTINUING DATA *****</b> <i>None</i> <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2000-214845 07/14/2000 <i>Jps</i> <b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 08/23/2001</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>kl</i> Examiner's Signature Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 3	<b>TOTAL CLAIMS</b> 4	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> ADAMS & WILKS 31st Floor 50 Broadway New York ,NY 10004					
<b>TITLE</b> Wafer pattern observation method and device					
<b>FILING FEE RECEIVED</b> 840	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		